

In re Application of:

TAKAO YONEHARA, ET AL.

Application No.: 10/059,144

Filed: January 31, 2002

For: METHOD OF MANUFACTURING  
THIN-FILM SEMICONDUCTOR  
DEVICE

Docket No. 00862.022498

Examiner: Brook Kebede

Group Art Unit: 2823

Date: November 22, 2004

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

| CLAIMS AS AMENDED                             |   |       |                                       |                  |                |                   |
|---|---|-------|---------------------------------------|------------------|----------------|-------------------|
|   | CLAIMS<br>REMAINING<br>AFTER<br>AMENDMENT |       | HIGHEST NO.<br>PREVIOUSLY<br>PAID FOR | PRESENT<br>EXTRA | RATE           | ADDITIONAL<br>FEE |
| TOTAL<br>CLAIMS                               | 10  | MINUS | 20                                    | 0                | x \$9<br>\$18  | 0                 |
| INDEP.<br>CLAIMS                              | 3   | MINUS | 3                                     | 0                | x \$43<br>\$86 | 0                 |
| Fee for Multiple Dependent claims \$145/\$290 |   |       |                                       |                  |                |                   |
| TOTAL ADDITIONAL FEE<br>FOR THIS AMENDMENT--- |   |       |                                       |                  |                | 0                 |

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

☐ A check in the amount of \$\_\_\_\_ is enclosed.

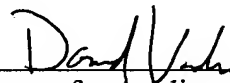
☐ Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.

☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

☐ A check in the amount of \$\_\_\_\_ to cover the fee for a \_\_\_\_ month extension is enclosed.

☐ A check in the amount of \$\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our Washington office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

  
\_\_\_\_\_  
Attorney for Applicants  
Damond E. Vadnais  
Registration No.: 52,310

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3800  
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00862.022498



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|                              |   |                        |
|------------------------------|---|------------------------|
| In re Application of:        | ) |                        |
|                              | : |                        |
| TAKAO YONEHARA, ET AL.       | ) | Examiner: Brook Kebede |
|                              | : |                        |
| Application No.: 10/059,144  | ) | Group Art Unit: 2823   |
|                              | : |                        |
| Filed: January 31, 2002      | ) |                        |
|                              | : |                        |
| For: METHOD OF MANUFACTURING | ) |                        |
| THIN-FILM SEMICONDUCTOR      | : |                        |
| DEVICE                       | ) | November 22, 2004      |

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, and in response to the Office Action dated August 25, 2004, please amend the above-referenced application as follows: